



Attorney Docket No. 0756-2393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Ritsuko KAWASAKI et al.

Serial No. 09/988,389

Filed: November 19, 2001

For: LASER IRRADIATION METHOD AND
METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

) Group Art Unit: 2818

) Examiner: D. Vu

) CERTIFICATE OF MAILING

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) Rose J. Jones

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2/1/06
1/25/06
1/30/06*

AFTER FINAL AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated September 28, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 23 of this paper.